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5/5/2010 DOCKET NO: 263787US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIROSHI MASHIMA, ET AL. : EXAMINER: GAMBETTA, KELLY M.
SERIAL NO: 10/518,371 :
FILED: DECEMBER 28, 2004 : GROUP ART UNIT: 1792
FOR: METHOD FOR PLASMA- :
ENHANCED CHEMICAL VAPOR
DEPOSITION AND APPARATUS FOR
PLASMA-ENHANCED CHEMICAL
VAPOR DEPOSITION

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

The Request for Reconsideration is in response to the Office Action of January 29,
2010.

Remarks/Arguments begin on page 2 of this paper.